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CONFIRMATION NO. 7302

SERIAL NUMBER 09/942,038	FILING DATE 08/30/2001 RULE	CLASS 438	GROUP ART UNIT 2813	ATTORNEY DOCKET NO. 0819-0637	
APPLICANTS Yoshihiro Mori, Osaka, JAPAN; Yasutoshi Okuno, Kyoto, JAPAN; Akihiko Tsuzumitani, Osaka, JAPAN; ** CONTINUING DATA ***** <i>N/A</i> ** FOREIGN APPLICATIONS ***** JAPAN 2000-265284 09/01/2000 <i>JD</i> IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 10/15/2001					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <i>[Signature]</i> Examiner's Signature <i>[Initials]</i>		STATE OR COUNTRY JAPAN	SHEETS DRAWING 9	TOTAL CLAIMS 15	INDEPENDENT CLAIMS 4
ADDRESS 22204 NIXON PEABODY, LLP 401 9TH STREET, NW SUITE 900 WASHINGTON, DC 20004-2128					
TITLE Method for fabricating semiconductor device including annealing an electrode in a reducing atmosphere before capacitor insulating film forming					
FILING FEE RECEIVED 1242	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		